

Notice of References Cited

Application/Control No.

10/797,188

Applicant(s)/Patent Under
Reexamination
EMA ET AL.

Examiner

MAHMOUD DAHIMENE

Art Unit

1792

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
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FOREIGN PATENT DOCUMENTS

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	O					
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	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf and R.N. Tauber, (Silicon Processing for the VLSI Era, Volume 1- Process Technology, Lattice Press, 1986) (pp. 526-528)
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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